



ALYSSA H. RUDERMAN

ASSOCIATE

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Alyssa Ruderman is an intellectual property associate skilled in patent law and litigation. She works with clients to license, enforce and expand their patent portfolios, as well as petition for *inter partes* review.

With experience representing clients in negotiations and litigation against major multinational electronics companies, Alyssa is skilled in both U.S. and foreign patents and patent applications, as well as drafting, negotiating and enforcing licenses and settlement agreements. She conducts due diligence analysis and has experience with patent mining and liaising with expert witnesses. She drafts complaints, *Markman* briefs and other motions and pleadings related to patent litigation, and works with patent prosecution counsel to assist with obtaining additional patent rights.

BACKGROUND

Prior to joining Armstrong Teasdale, Alyssa was an associate at other New York City and Boston law firms. During law school, she was a legal extern for the University of North Carolina Chapel Hill Office of Technology Development and for the New Hampshire Supreme Court Attorney Discipline Office.

EDUCATION

- University of New Hampshire Franklin Pierce School of Law (J.D., 2015)
 - University of New Hampshire Law Review, Managing Board, Executive Editor
 - Student Bar Association, Secretary
 - Student Intellectual Property Law Association, Class Chair
 - Hillel, President
 - Phi Alpha Delta, Treasurer
 - Merrimack County Juvenile Diversion Program, Mentor
- Rensselaer Polytechnic Institute (B.S., 2012)
 - Biology, Psychology
 - Dean's List
 - Jeanne and Frank Fischer '64 Scholarship for Advancement in Biotechnology
 - Rensselaer Merit Scholarship for Academic Excellence

PROFESSIONAL ACTIVITIES

SERVICES AND INDUSTRIES

Intellectual Property

Intellectual Property Litigation

Litigation

Patent

Technology

ADMISSIONS

Massachusetts

New Jersey

New York

- Alan D. Laurie Boston Intellectual Property American Inn of Court